

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
		:	Examiner: Hai Vo
HIRC	OKATSU MIYATA)	•
		:	Group Art Unit: 1771
Application No.: 09/657,616)	
		:	
Filed: September 8, 2000)	
		:	
For:	MESOSTRUCTURED THIN FILM,)	
	MESOPOROUS THIN FILM, AND	:	
	PROCESS FOR PRODUCTION)	
	THEREOF	:	September 23, 2004

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT IN RESPONSE TO FINAL REJECTION

Sir:

a) <u>Introductory Comments</u>

In response to the Final Official Action dated June 28, 2004, kindly amend the subject application as follows: